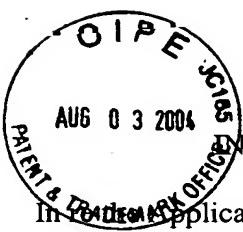


PATENT APPLICATION



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Yasuaki HAMADA et al.

Group Art Unit: 3729

Application No.: 10/807,357

Filed: March 24, 2004

Docket No.: 119223

For: FERROELECTRIC MATERIAL, FERROELECTRIC FILM AND METHOD OF  
MANUFACTURING THE SAME, FERROELECTRIC CAPACITOR AND METHOD OF  
MANUFACTURING THE SAME, FERROELECTRIC MEMORY AND  
PIEZOELECTRIC DEVICE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- 2. A co-pending U.S. patent application is identified on Form PTO 1449 of this Information Disclosure Statement. The Examiner is respectfully requested to consider each cited application and the art cited therein during examination of the present application.

Respectfully submitted,

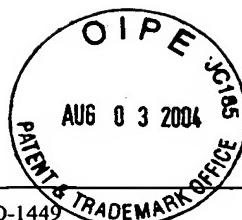
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Date: August 3, 2004

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Sheet 1 of 1

Date: August 3, 2004